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R.F. Magnetron Sputtered Li-Mn-O Films for Li-Ion Batteries: Combined XPS and ToF-SIMS Characterization M. Bruns^{1,2,*}, J. Fischer¹, H. Ehrenberg¹, H.J. Seifert¹, S. Ulrich¹

Most of currently available lithium-ion batteries operate with toxic and highly flammable liquid electrolytes bearing risks of leakage, ignitability and undesirable side-reactions. To overcome these problems a very promising approach is the development of all-solid-state-LIBs by means of thin-film technology. Such batteries consist of a solid multilayer stack of cathode, electrolyte and anode thin films of about 3 µm overall thickness [1]. The present study focusses on the surface analytical characterization of environmental friendly Li-Mn-O based thin film cathodes fabricated by means of combined R.F. magnetron sputtering and furnace annealing [2]. ToF-SIMS and XPS allows for quantitative information on the uniformity of the as prepared thin films as well as of the atomic and/or ionic inter-diffusion of the layer constituents at the contact interface (cathode and current collector) during annealing. Special care was taken to widely guarantee atmosphere-contact-free sample transport.

Preparation:



Film deposition by R.F. magnetron sputtering

- Substrates: stainless steel discs, 12 mm diam. x 0.5 mm thickness
- Interlayer: 100 nm Gold
- Targets: $LiMn_2O_4$ (CERAC Inc., USA) Li_2MnO_2 (MaTecK GmbH, Germany)
- Annealing: 100 nm thick films using the $LiMn_2O_4$ -target: 30 min at 700 °C in ambient air (~1000 hPa) 100 nm thick films using the Li_2MnO_2 -target: 30 min at 665 °C under vacuum (5×10⁻³ Pa)

Characterization:





X-ray Photoelectron Spectroscopy (XPS):

- ThermoFisher Scientific K-Alpha spectrometer
- Micro-focused mono-AlKα X-ray source
- 1 keV Ar⁺ sputter depth profiles

Time-of-Flight Secondary Mass Spectrometry (ToF-SIMS):

ION-TOF GmbH ToF.SIMS⁵ spectrometer

- Bi+, pos. & neg. polarity
- 2 keV Cs⁺ sputter depth profiles

Atmosphere-contact-free sample handling



sputter time [s]

sputter time [s]

sputter time [s]

sputter time [s]

Quantitative depth resolved elemental composition of thin film cathodes, anodes and solid Combined ToF-SIMS and XPS measurements can help to improve:

- the adhesion and electrical contact between current collector and electrode materials
- the solid electrolyte interface (SEI) and artificial SEIs
- protective coatings to prevent Mn²⁺-dissolution into acidic liquid electrolytes
- Li⁺ diffusion barriers, Li⁺ transport processes, and corrosion behavior

Conclusions

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state electrolytes

film cathode

Combined ToF-SIMS and XPS allows for quantitative information on the uniformity of the as prepared thin films as well as on diffusion processes during annealing

Detailed information on elemental diffusion processes between substrate, interface and thin

- The depth profiles give hints on reaction layers at the thin film surface and the substrate to cathode interface
- Post mortem analysis for investigation of the degradation mechanisms after electrochemical cycling are possible

References

 J.B. Bates, N.J. Dudney, B. Neudecker, A. Ueda, C.D. Evans, Solid State Ionics, 135 (2000) 33-45.
 J. Fischer, C. Adelhelm, T. Bergfeldt, K. Chang, C. Ziebert, H. Leiste, M. Stüber, S. Ulrich, D. Music, B. Hallstedt, H.J. Seifert, Thin Solid Films, 528 (2013) 217-223.

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→ Influence of ambient air on the topmost surface of the battery active materials

